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NEC-2370-US
Amendment dated 10/18/2004

09/853,622

04150012aa

Reply to office action mailed 08/18/2004

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of

Kazuhiko Hayashi

Serial No. 09/853,622

Group Art Unit 2652
Technology Center 2600

Filed May 14, 2001

Examiner C. Renner

For **MAGNETORESISTIVE EFFECT SENSOR, METHOD FOR
MANUFACTURING A MAGNETORESISTIVE EFFECT SENSOR,
MAGNETORESISTIVE DETECTION SYSTEM, AND
MAGNETORESISTIVE RECORDING SYSTEM**

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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OCT 21 2004

AMENDMENT UNDER 37 C.F.R. §1.116

*Do Not Enter
C.R./10-08*
Sir:

In response to the Office Action mailed August 18, 2004, please amend the above-identified patent application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are indicated by the notation "currently amended" in the listing of claims beginning on page 3 of this paper.

Remarks begin on page 9 of this paper.

BOX "AF"
RESPONSE UNDER 37 C.F.R. § 1.116
---EXPEDITE PROCEDURE---
EXAMINING GROUP _____